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Robert S. Zeller and Russell J. Holmes

Title: LITHOGRAPHIC PROJECTION APPARATUS,  
PURGE GAS SUPPLY SYSTEM AND GAS  
PURGING METHOD

Attorney's Docket No.: 3194.1033-013

Date: 20 January 2006

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PRELIMINARY AMENDMENT

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the application as follows: